



V, I, R measurements

590B

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September 23, 2009

SI units/History

Resistivity measurements



First reliable source of
electricity
Alternating
plates of Zn and Cu
separated by cardboard
soaked in saltwater

Electrical action is
proportional to the number
of plates



Alessandro Giuseppe Antonio Anastasio Volta

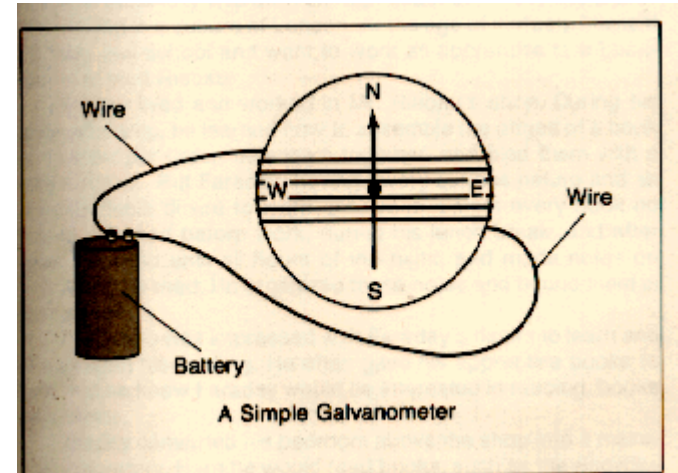
1745-1827

Count (made by Napoleon 1810)

1881- Volt unit adopted internationally



André-Marie Ampère
1775 - 1836



Months after 1819 Hans Christian Ørsted's discovery of magnetic action of electrical current

1820 Law of electromagnetism (Ampère's law)
magnetic force between two electric currents.

First measurement technique for electricity
Needle galvanometer



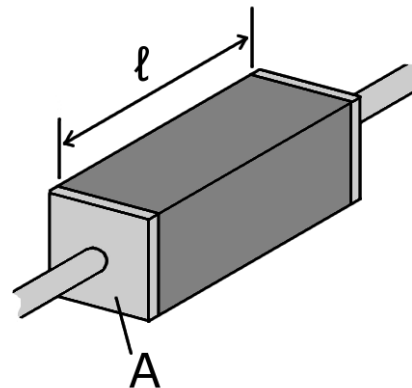
Georg Simon Ohm
1789 - 1854

$$\mathbf{I=V/R}$$

1826 Ohm's apparatus

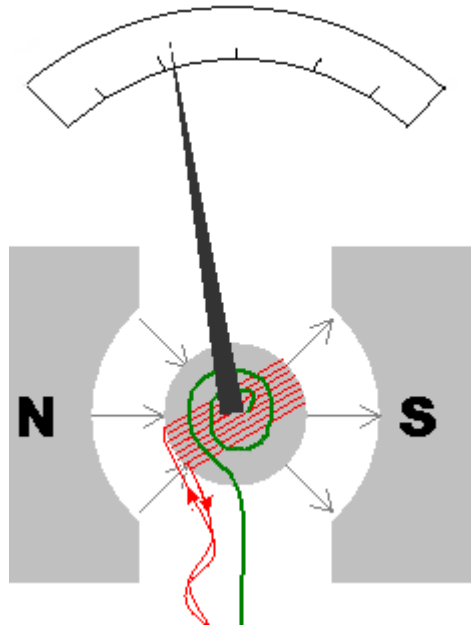
Current measurement:
magnetic needle

Voltage source:
thermocouple (Seebeck 1821)
Steam heater
Ice cooler



Resistivity

$$\rho = R \frac{A}{\ell}$$



Can be measured via
Magnetic action of electric current
Heat
Mass flow (electrolysis)
Light generation
Physiological action (Galvani,
You can do anything with cats!)

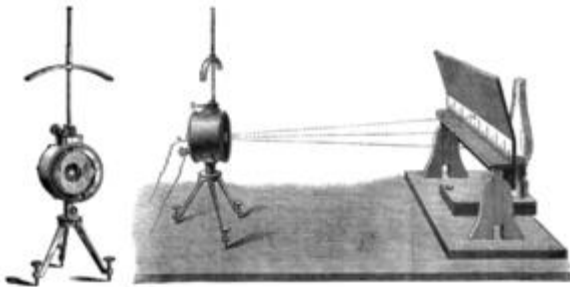


D'Arsonval galvanometer

Ampere main SI unit:

Definition based on force of
interaction between parallel current

Replaced recently
Amount of deposited mass per
unit time in electrolysis process

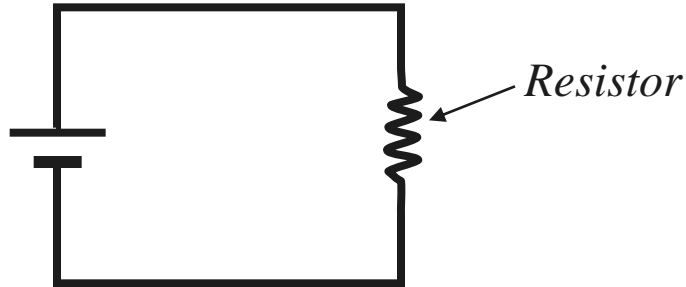


Thompson (Kelvin) mirror galvanometer

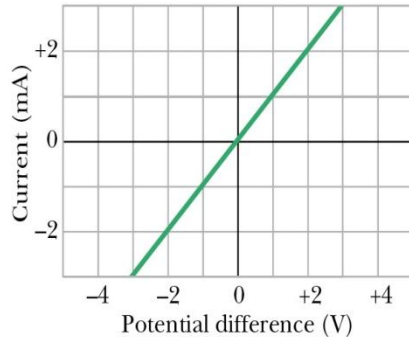
Our common experience: resistance is the simplest quantity to measure

True, but only inside "comfort zone"

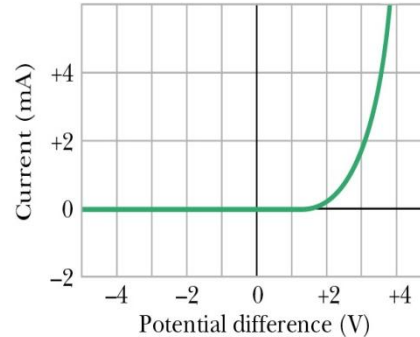
Use Ohm's law



Apply known I (V) Measure V (I)
Calculate resistance



(b)



(c)

Implicit: Ohm's law is valid for our measurement object, I-V curve is linear
May be far from true!

Implicit: our whole circuit is linear and no offsets!
Assumption: wire resistance is negligible

Digital Multi Meters -
DMM

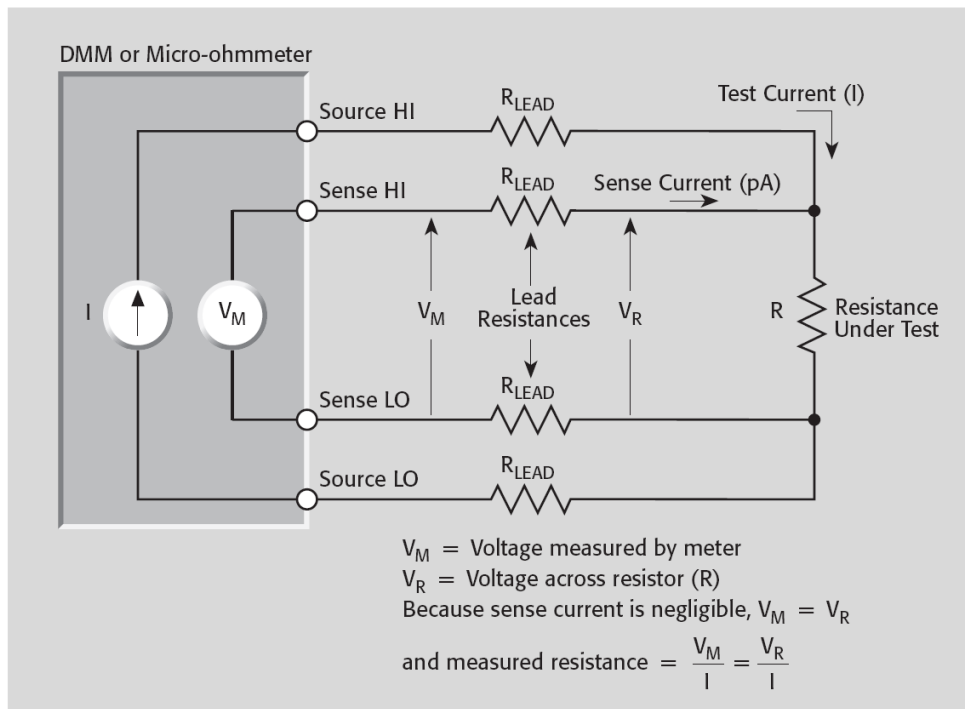


Typical characteristics
1 mV per last digit
1 μ A per last digit
High input offset current
Low input impedance

Resistance 4-probe measurements (Kelvin probe measurement)

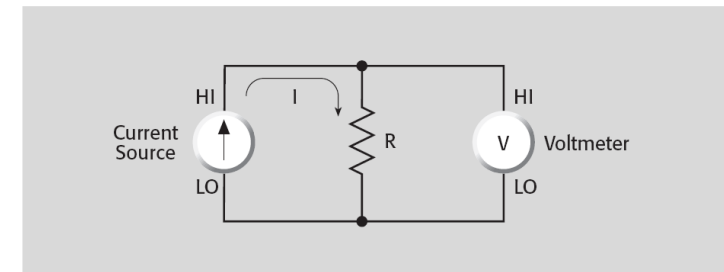
To minimize wire resistance effect for remote objects
To minimize the effect of contacts for resistivity measurements
Even allows slightly rectifying contacts
and “high” resistance contacts

FIGURE 3-15: Four-Wire Resistance Measurement



Current source in one circuit
Potential voltage measurement
in ANOTHER circuit

FIGURE 2-31: Constant-Current Method Using a Separate Current Source and Voltmeter

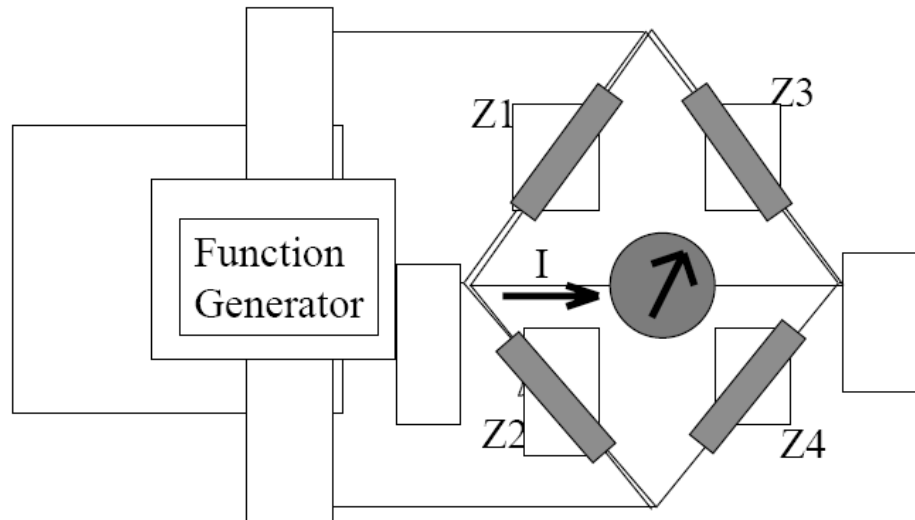


Thanks Adam!

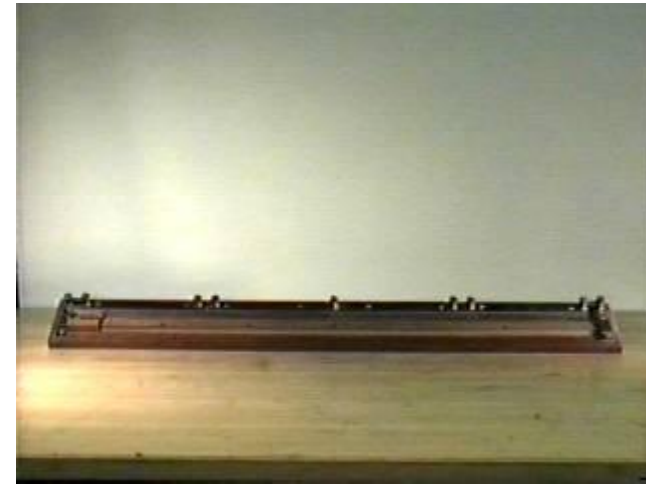
Resistance: bridge measurement

At balance $I = 0$

$$Z1 \cdot Z4 = Z2 \cdot Z3$$



Slide Wire Wheatstone Bridge



Resistance Decade Bridge

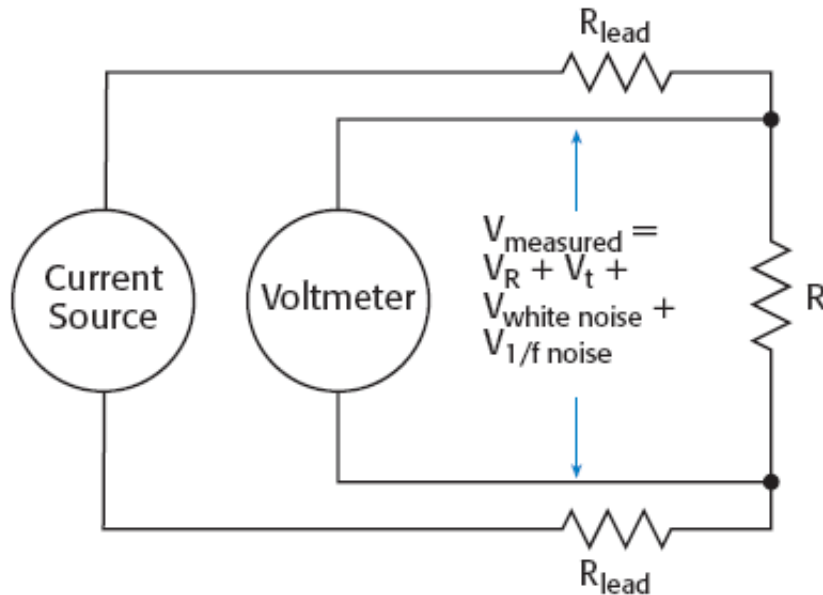


Replaces I and V measurement by resistance compensation to obtain zero reading
No effect of circuit non-linearity,
In old days PRECISE DIGITAL measurement

Does not go well with modern electronics

Resistance 4-probe measurements

Consideration of noise sources



Wires generate spurious DC Voltages

- Thermoelectric (thermal gradients) 1/f noise
- Galvanic (oxidation) 1/f noise
- RF interference and rectification in contacts

$$V_M = IR + V_{\text{offset}}$$

DC Delta method
Measure at $I+$
Measure at $I-$
average



-Thermal EMF errors
Most common source in low level
Voltage measurements

Each wire junction forms
a thermocouple

-Galvanic potentials in contacts
Gold plating to avoid oxidation

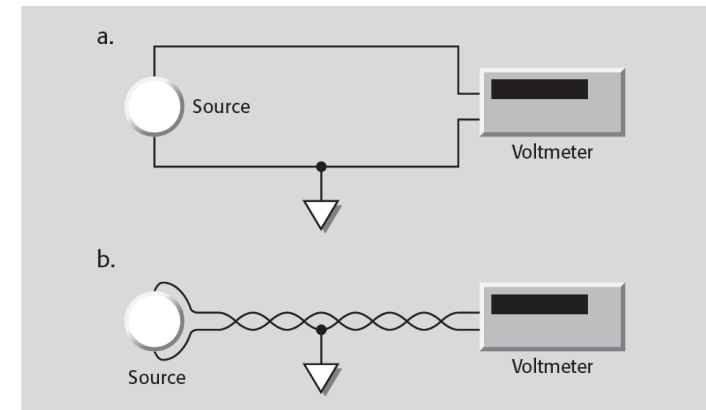
-Noise caused by magnetic fields

Extremely important for AC measurements
Wires vibrate and AC voltage generated

Twisted pairs
Fixed wires

Copper-to-	Approx. $\mu\text{V} / ^\circ\text{C}$
Copper	< 0.3
Gold	0.5
Silver	0.5
Brass	3
Beryllium Copper	5
Aluminum	5
Kovar or Alloy 42	40
Silicon	500
Copper-Oxide	1000
Cadmium-Tin Solder	0.2
Tin-Lead Solder	5

FIGURE 3-10: Minimizing Interference from Magnetic Fields



Ground loops

Current source
and voltmeter
have grounded terminals

Grounds are not ideal and
are under some potential

Devices grounded
in different points acquire
potential difference which
contributes to the measured signal

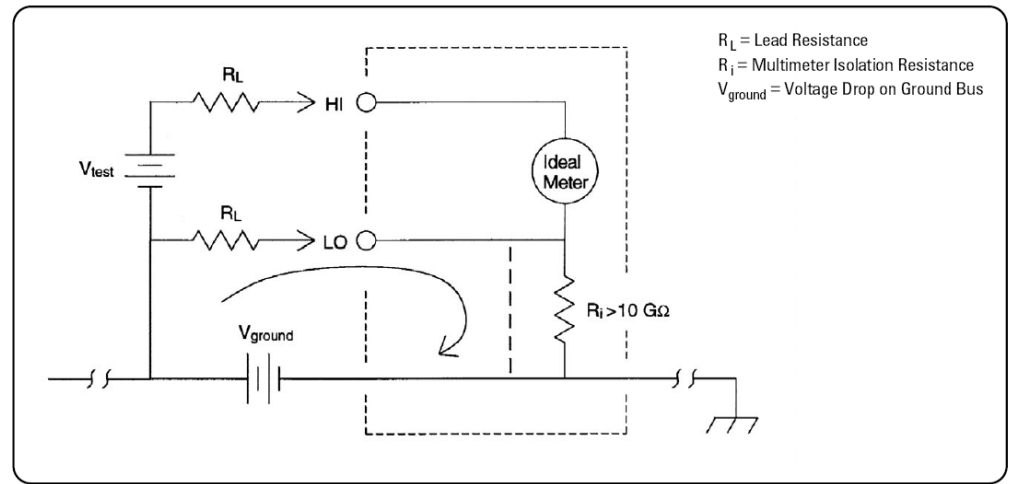


Figure 3.



Good

Bad

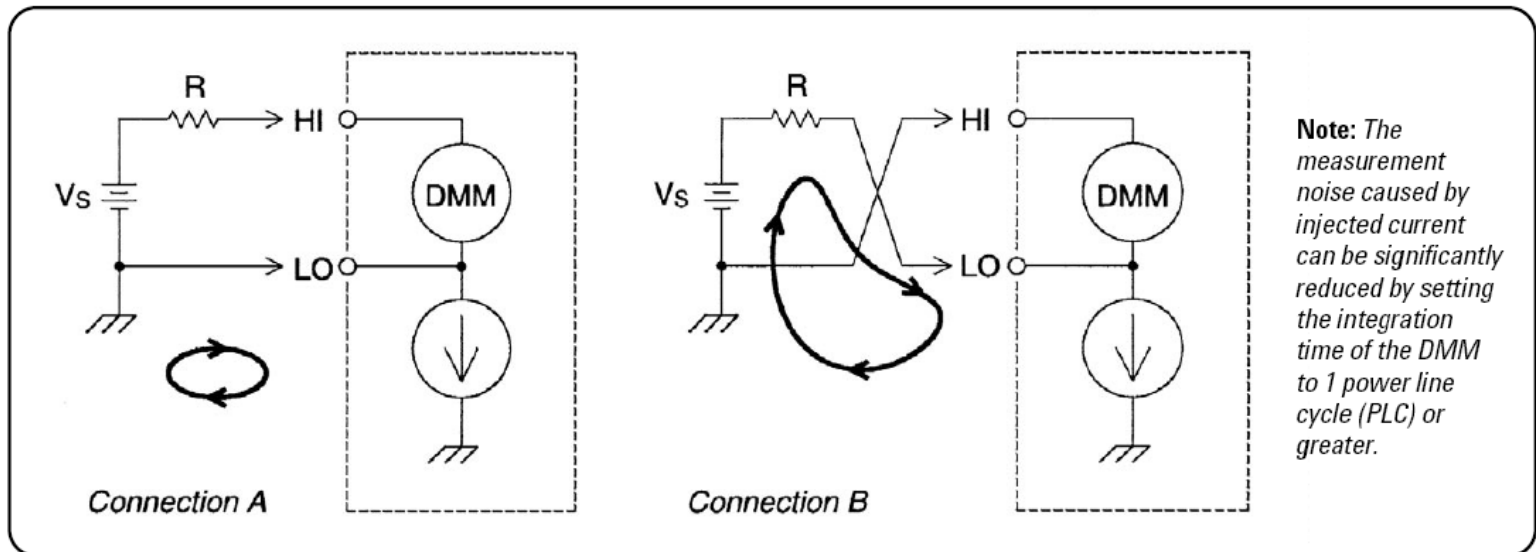


Figure 6.

Injected current bypasses
the measured resistance

Injected current flows through the
Measured resistance



Loading errors due to input resistance

Important for high resistance measurements

Typical

DC 10 GOhm

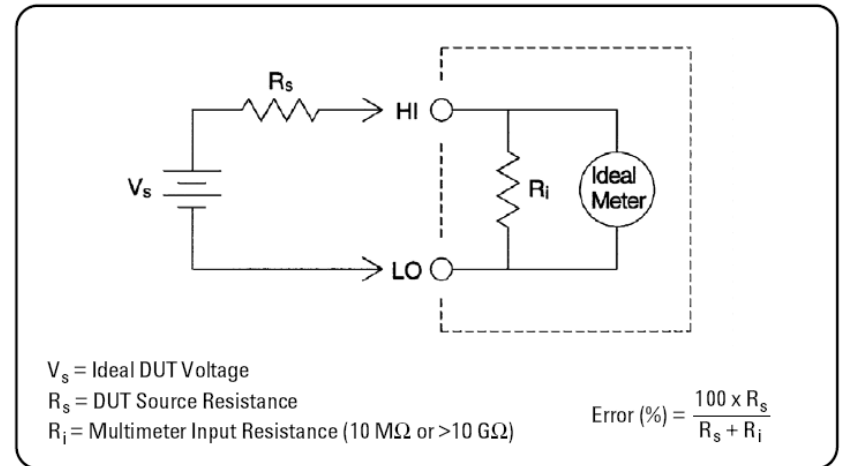


Figure 7.

Loading errors due to input bias current

AC 1 MOhm

100 pF

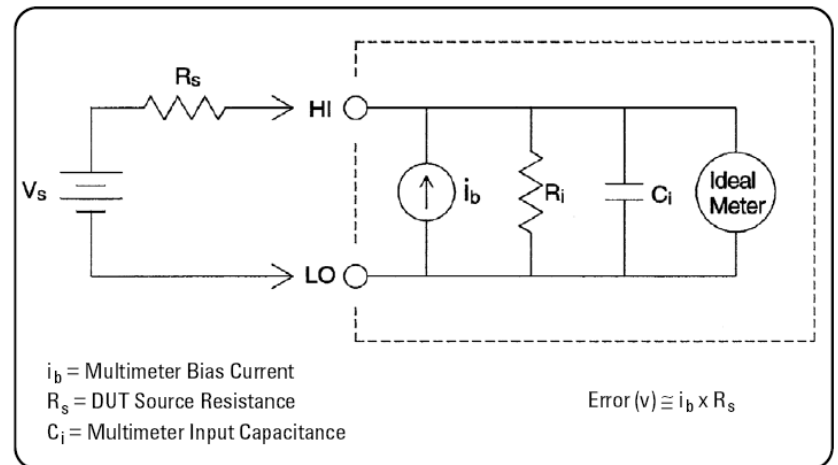
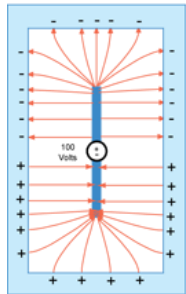


Figure 8.

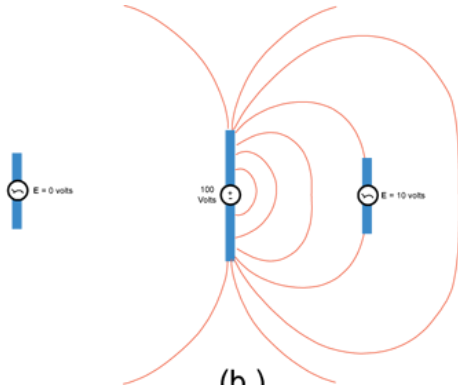


Shielding

Electrostatic Faraday cage

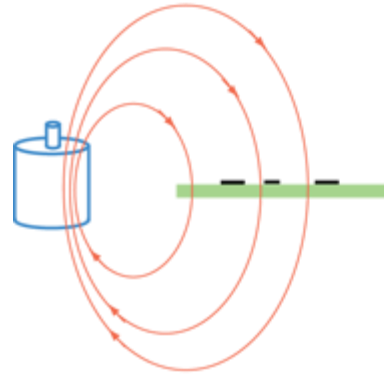


(a.)

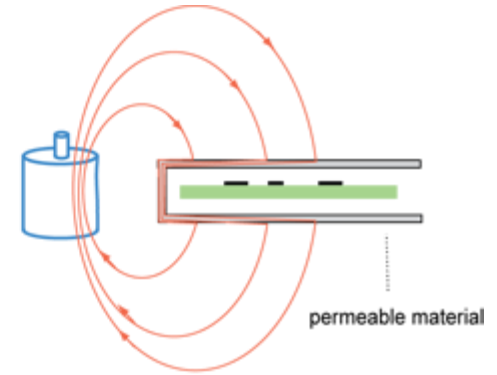


(b.)

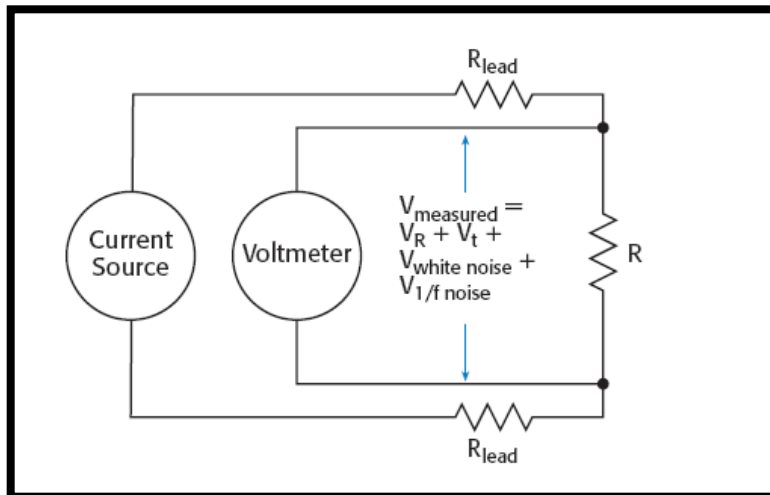
Magnetic shielding



(a.)



(b.)

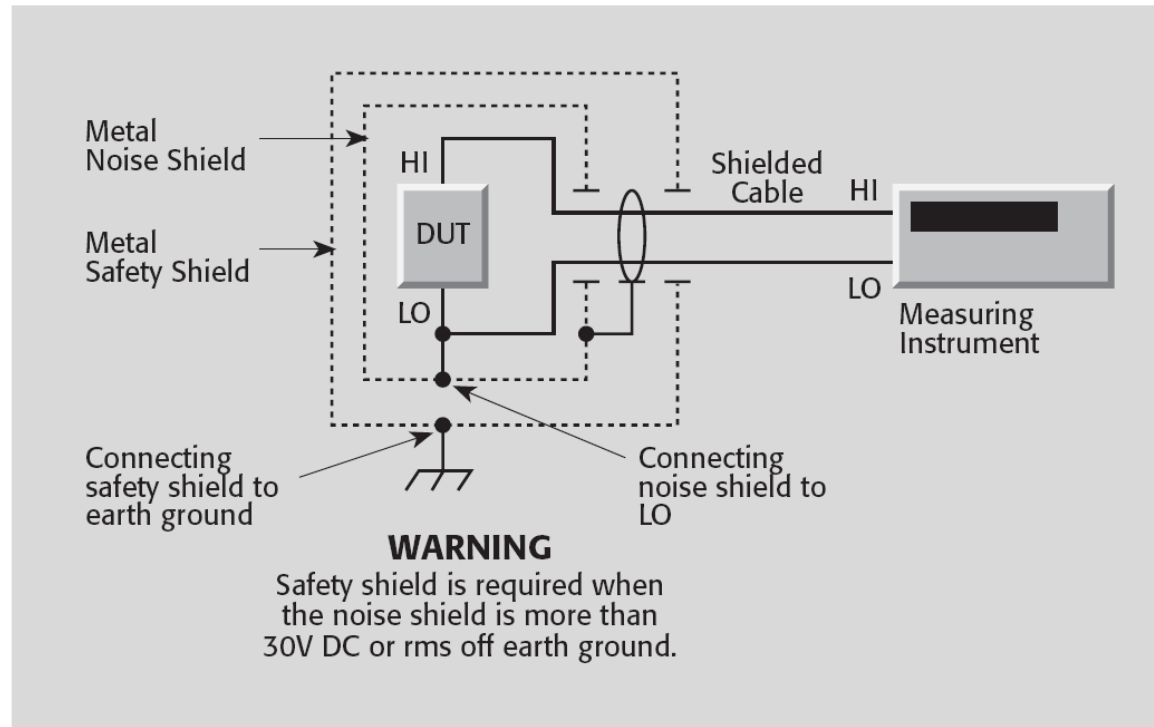


To prevent EMI

Unfortunately not very useful
In the lab, can not put electronics at low T

Shielding

FIGURE 3-6: Shielding to Attenuate RFI/EMI Interference



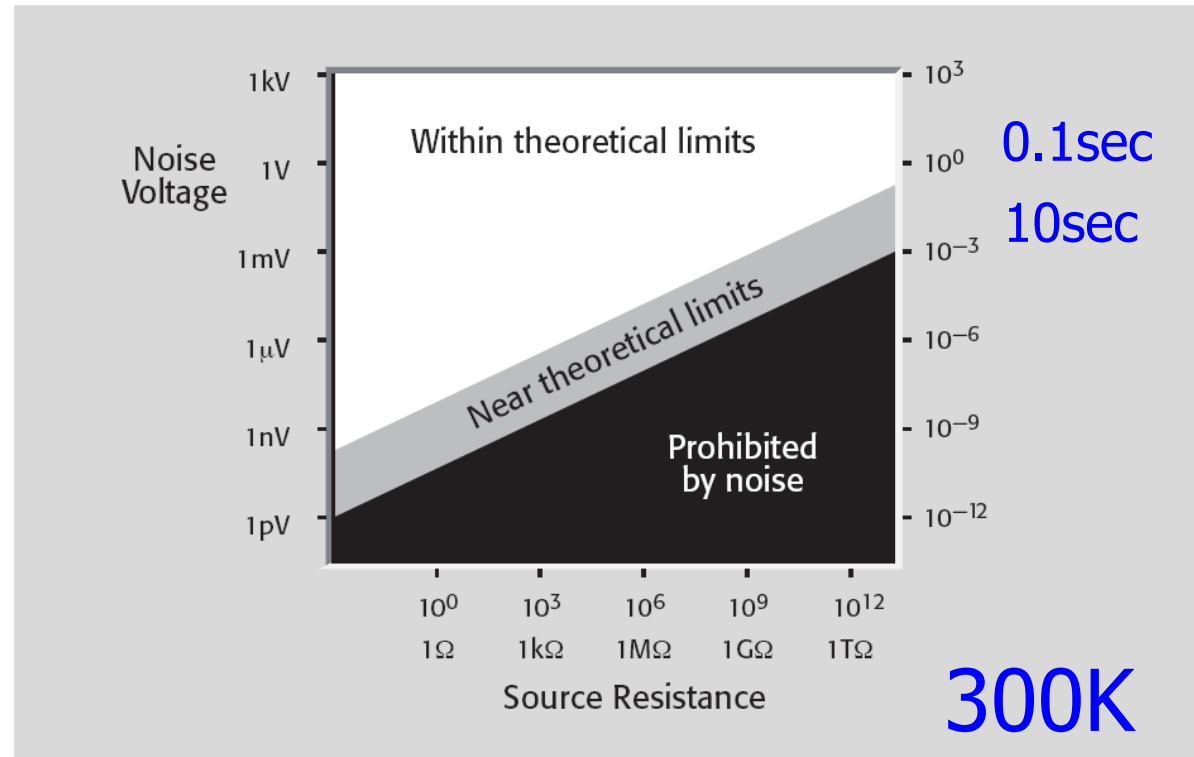
General rule

Avoid grounds in measurement circuits

Ground shields



FIGURE 1-2: Theoretical Limits of Voltage Measurements



Johnston noise

voltage

$$E = \sqrt{4kTRB} \text{ volts, rms}$$

current

$$I = \frac{\sqrt{4kTRB}}{R} \text{ amperes, rms}$$

B bandwidth

6th
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Low Level Measurements Handbook

Precision DC Current, Voltage, and Resistance Measurements

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LLM

Going outside comfort zone: DC measurements

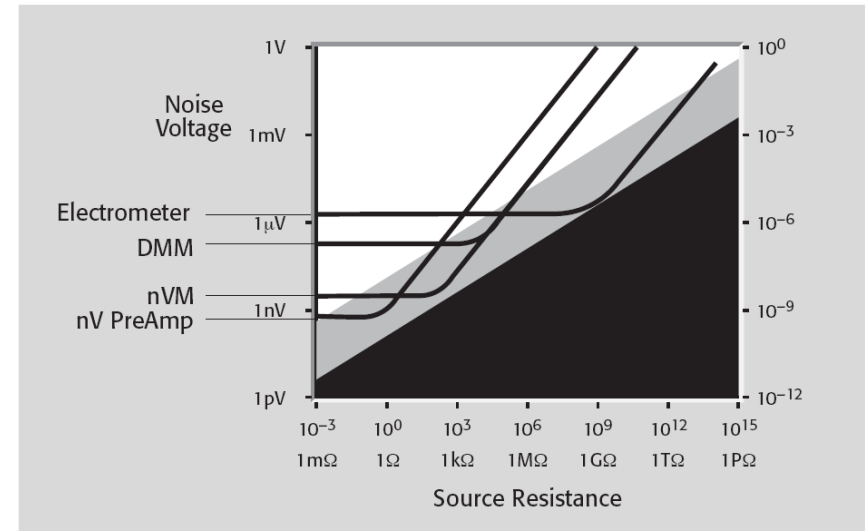
Special designs

High impedance source Electrometer
Used for $I < 10 \text{ nA}$, $G > 1 \text{ G}\Omega$
Input impedance $\sim 100 \text{ T}\Omega$
Input offset current $< 3 \text{ fA}$
Capable of R measurement up to
 $300 \text{ G}\Omega$

Low impedance source- Nanovoltmeter
 $< 1 \text{ nV}$

Source-measure units for
resistance measurements

FIGURE 1-3: Typical Digital Multimeter (DMM), Nanovoltmeter (nVM), Nanovolt Preamplifier (nV PreAmp), and Electrometer Limits of Measurement at Various Source Resistances



Here DMM
is from Keithley,
not from Fluke!

www.keithley.com

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Low resistances: AC may be a better choice

Lock-in resistance measurements
SR830
Built-in AC voltage generator

"Ohmic contacts" required for AC measurements

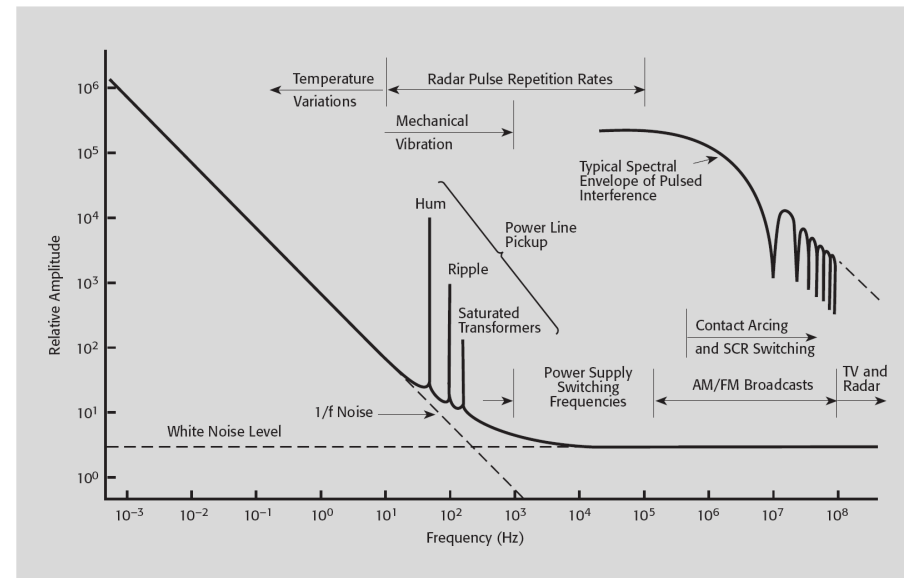
AC in differential mode
avoids offsets

Low frequency (below power grid, typically 10-20 Hz)

Problem: low input impedance,
Not good for high resistance sources

Problem: current source is not precise

Very popular simple and reasonably
precise resistance measurement



Low resistances: AC may be a better choice

Resistance bridges

LR700, AVS47, SIM927 and LS370

Actually these are not bridges!

Do not use compensation

Ratiometric resistance measurement

- **Low noise**
 - **Low excitation power**
 - **AC**
- Resistance measurements

AC to avoid offsets

Low frequency (below power grid, typically 10-20 Hz)

SIM927 Comparators measuring reference resistance voltage and in-phase component of sample resistance voltage



Specialized for low-temperature precision resistance measurements



Ways to reduce noise:

Reduce bandwidth

- averaging (digital or analog)
- filtering

Very long term measurements
are susceptible to other errors,
Temperature drift

Cool down the source

300K to 3K

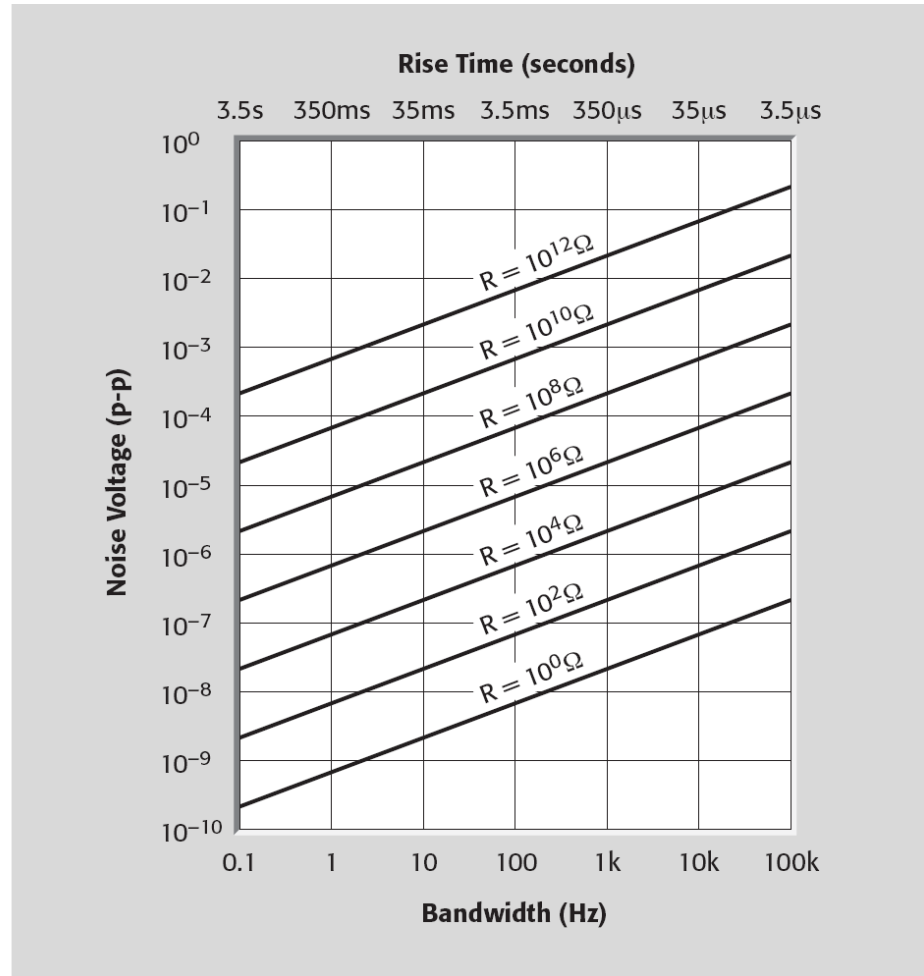
10 times noise decrease

Low temperature transformers and
Preamplifiers in DR

Source resistance

Low resistance contacts

FIGURE 2-52: Noise Voltage vs. Bandwidth at Various Source Resistances



The Delta Method of Measuring Resistance

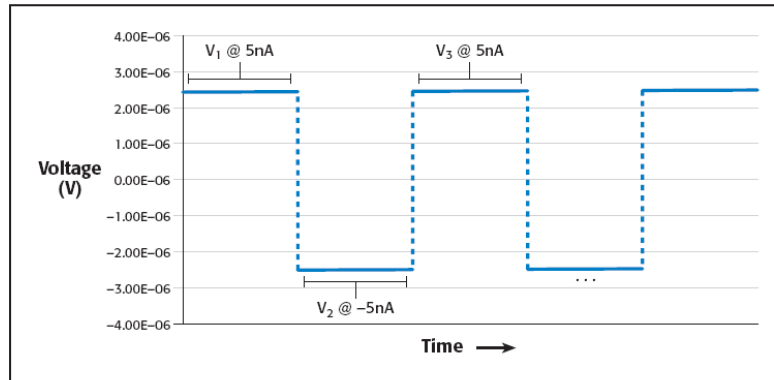


Figure 2a: The graph depicts an alternating, three-point delta method of measuring voltage with no thermoelectric voltage error.

$$V_1 = 2.5\mu\text{V} ; V_2 = -2.5\mu\text{V} ; V_3 = 2.5\mu\text{V}$$

3 point Delta Method

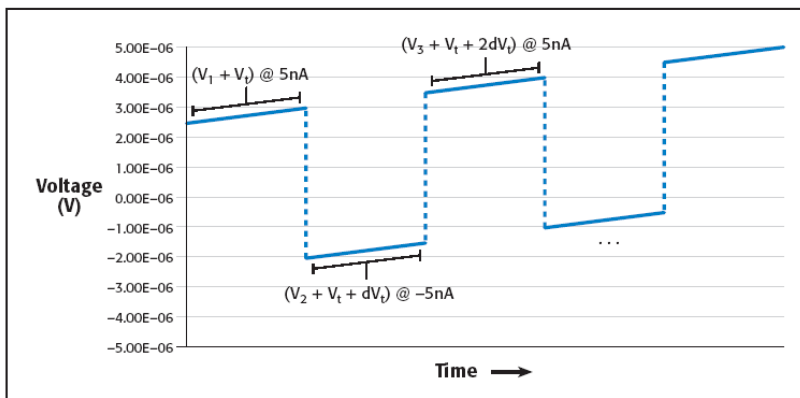


Figure 2b: A linearly increasing temperature generates a changing thermoelectric voltage error, which is eliminated by the three-point delta method.

$$V_a = \text{negative-going step} = (V_1 - V_2)/2 = 2.45 \mu\text{V}$$

$$V_b = \text{positive-going step} = (V_3 - V_2)/2 = 2.55 \mu\text{V}$$

$$V_f = \text{final voltage reading} = (V_a + V_b)/2 = \frac{1}{2}[(V_1 - V_2)/2 + (V_3 - V_2)/2] = 2.5 \mu\text{V}$$



**1000 Delta Resistance Readings
100 Ω Resistor, 10nA Source Current
Max. Thermal Voltage Rate of Change < 7 μ V/s**

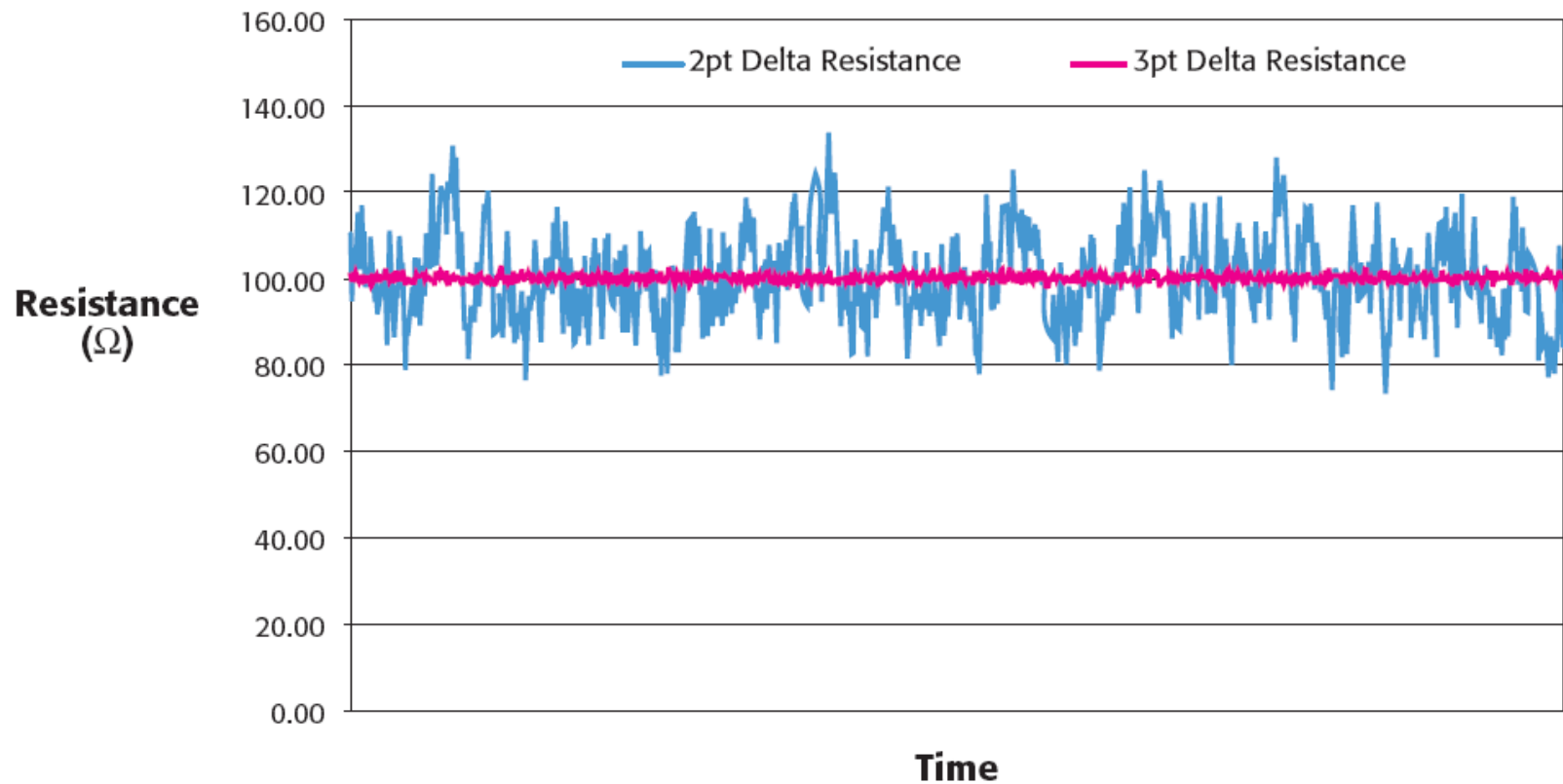


Figure 3: A graph comparing the results of applying a two- and three-point delta method shows significant noise reduction using the three-point method.

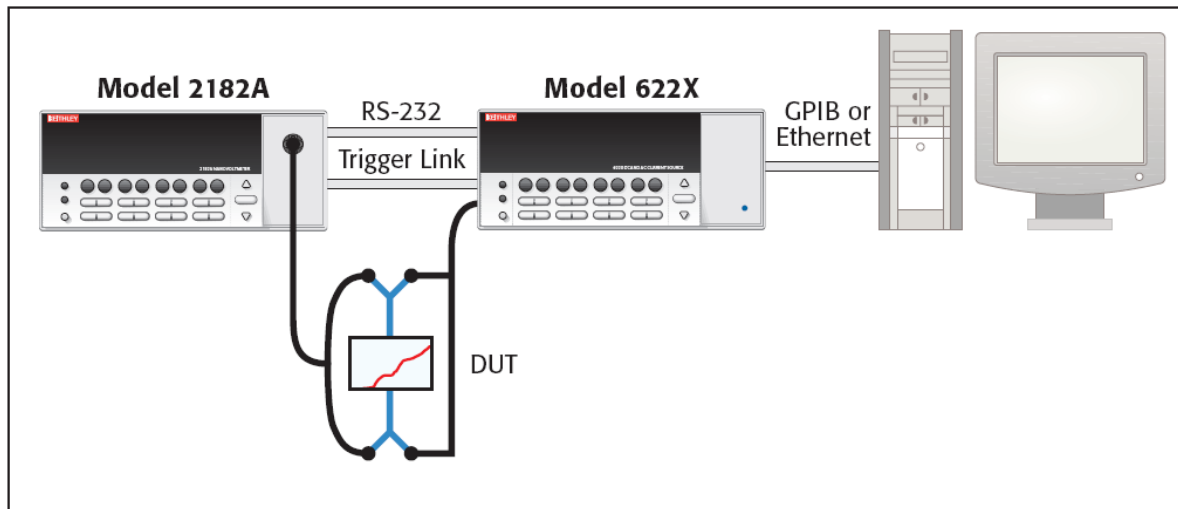


Figure 6: Making differential conductance measurements using just two instruments that incorporate all of the instruments used in the AC technique.

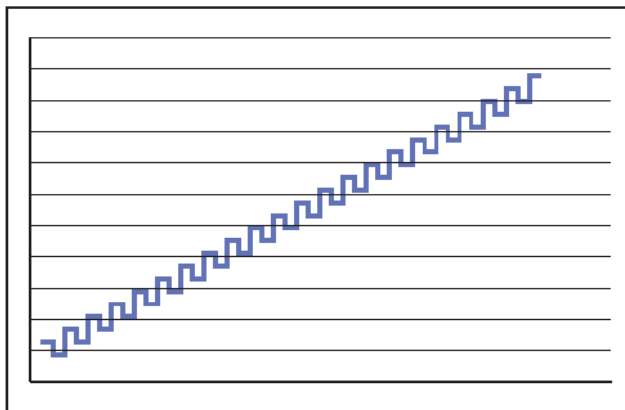
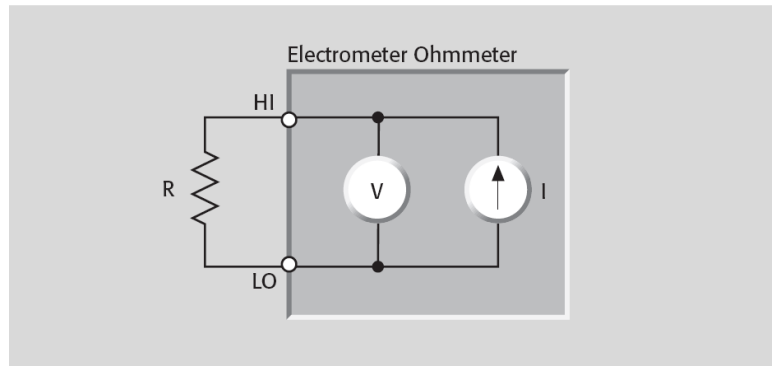


Figure 7: The waveform used in the new technique is a linear staircase function that combines an alternating current with a staircase current.

High resistance measurements

FIGURE 2-33: Electrometer Ohmmeter for Measuring High Resistance



Special features: Guarded cables
Triaxial connectors

FIGURE 2-34a: Effects of Cable Resistance on High Resistance Measurements

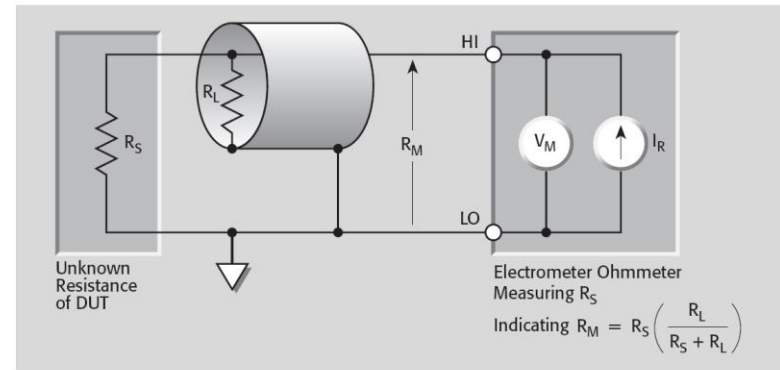


FIGURE 2-34b: Equivalent Circuit of Figure 2-34a Showing Loading Effect of Cable Leakage Resistance R_L .

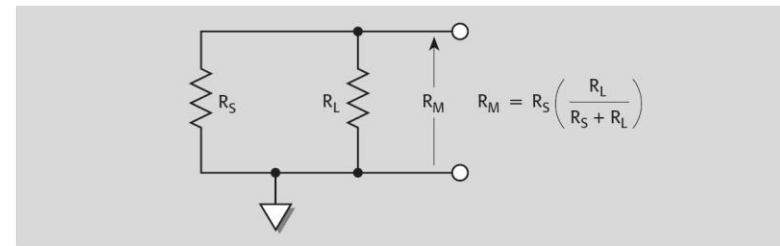
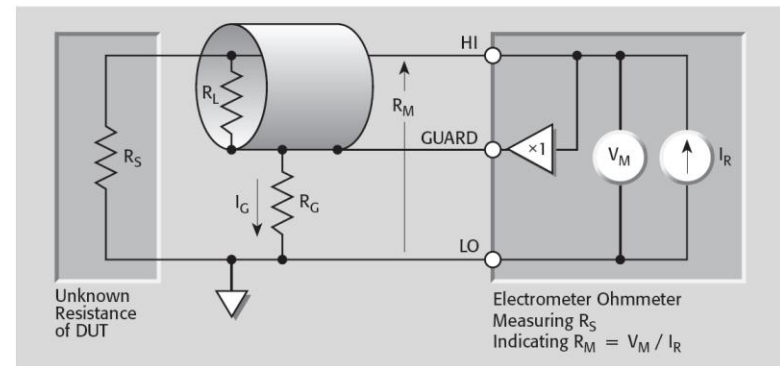


FIGURE 2-34c: Guarding Cable Shield to Eliminate Leakage Resistance



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High resistance measurements

Because of parasitic capacitance and high impedance only DC measurements

Important to make correct electrometer connections

FIGURE 2-40: Proper Connection

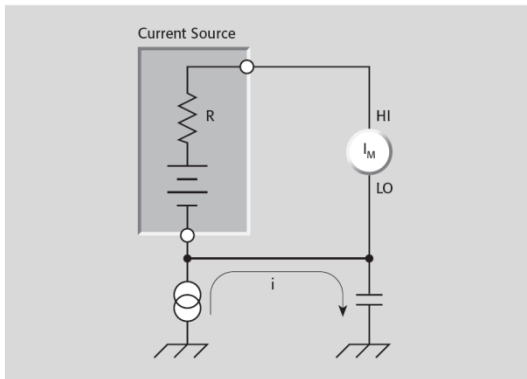


FIGURE 2-41: Improper Connection

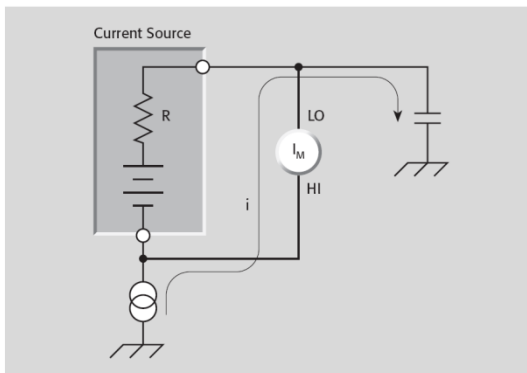


FIGURE 2-35: Settling Time is the Result of $R_S C_{SHUNT}$ Time Constant

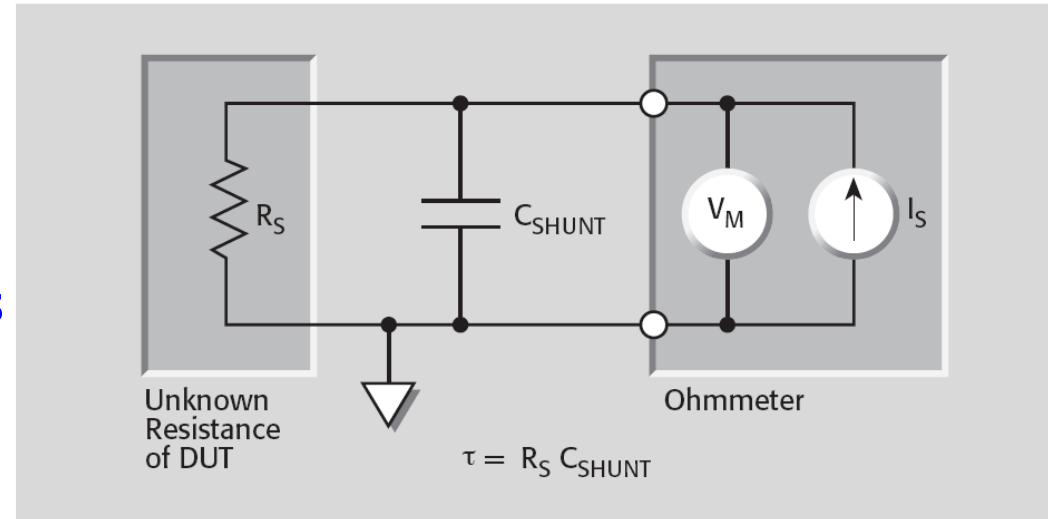
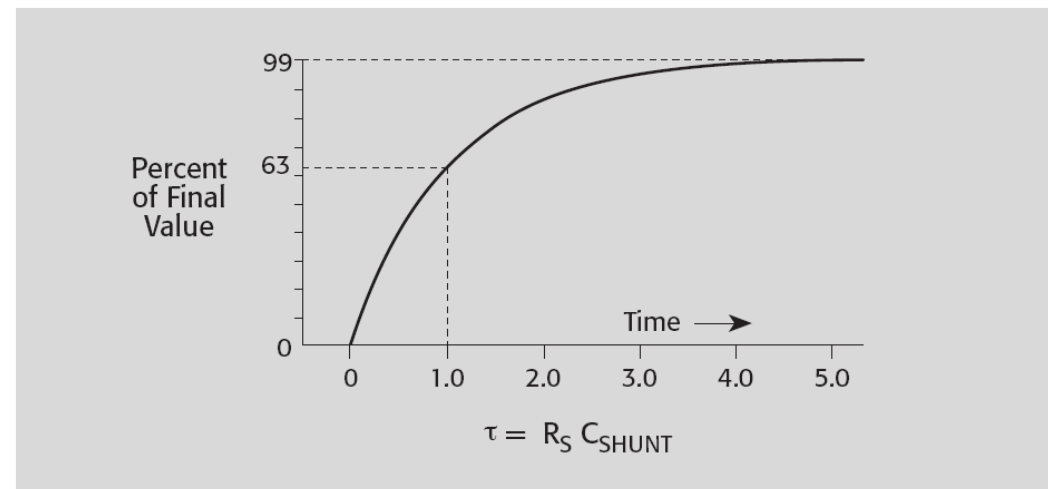


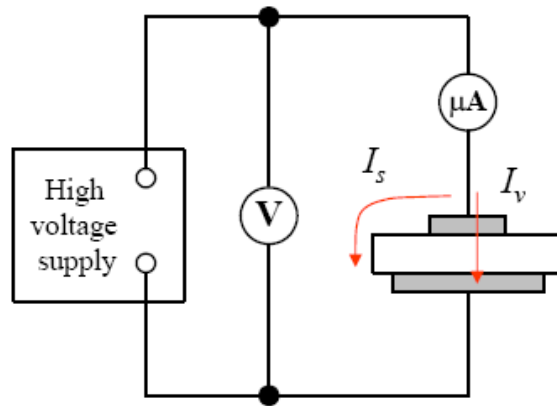
FIGURE 2-36: Exponential Settling Time Caused by Time Constant of Shunt Capacitance and Source Resistance



High resistance measurements

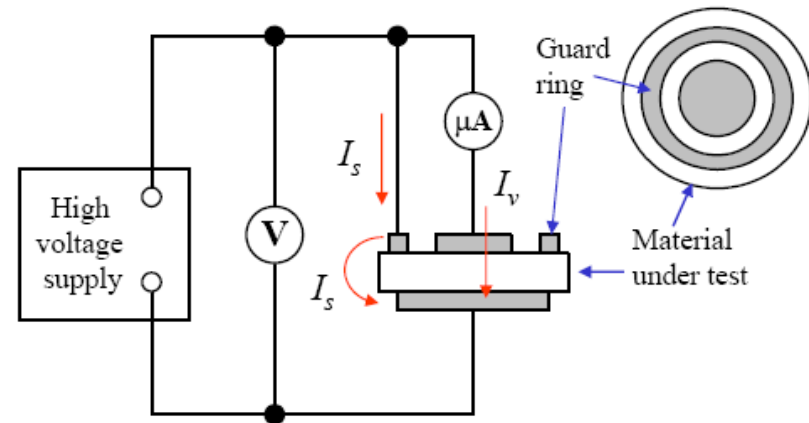
Guard ring technique:

- Volume resistance, R_v
- Surface leakage resistance, R_s



(a) Circuit that measures insulation volume resistance in parallel with surface leakage resistance

$$R_{meas} = R_s // R_v = \frac{V}{I_s + I_v}$$



(b) Use of guard ring to measure only volume resistance

$$R_{meas} = R_v = \frac{V}{I_v}$$

Resistivity measurements: 4-probe

“Ohmic contacts” required for AC measurements

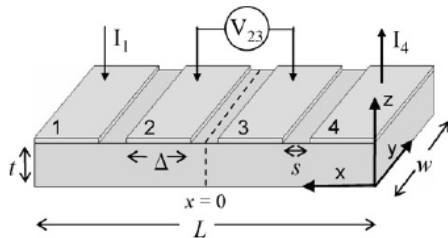
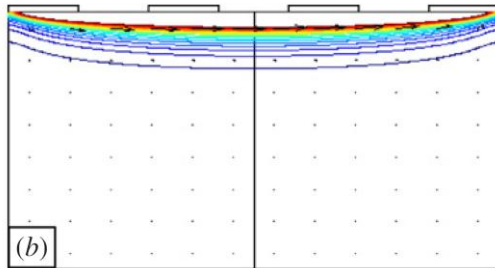
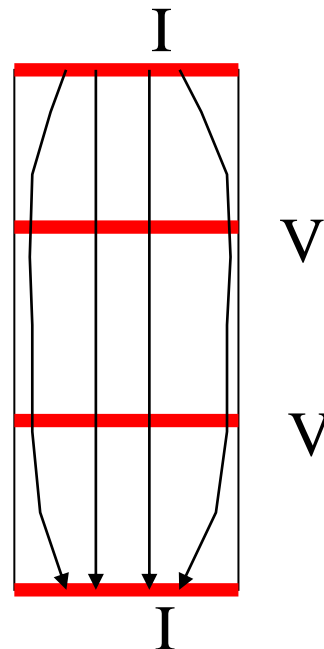


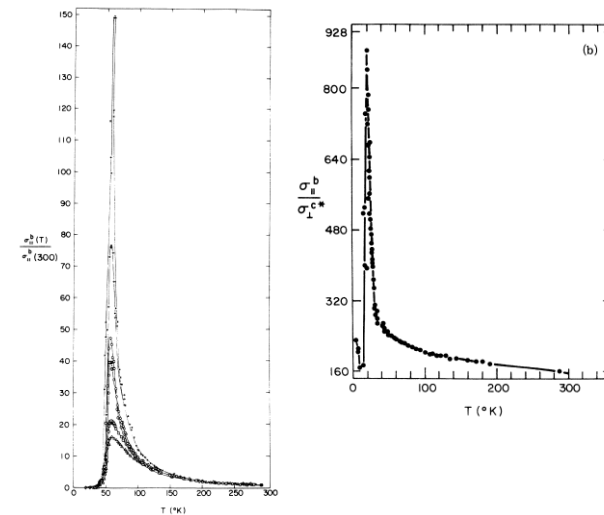
Figure 1. Schematic of the co-linear 4-probe configuration with electrodes that span the width of the specimen.



Strict requirements
on sample shape



Probably most
famous artefact



Concerns

Different I and V circuits

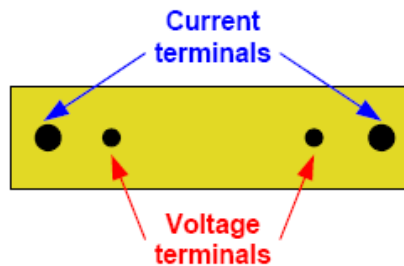
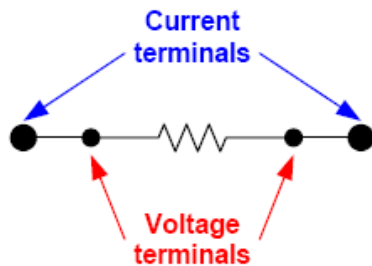
May be disconnected!

Potential contacts should
be connected well to current path

Superconducting fluctuations
and the Peierls instability
in an organic solid
SSC 12, 1125 (1973)

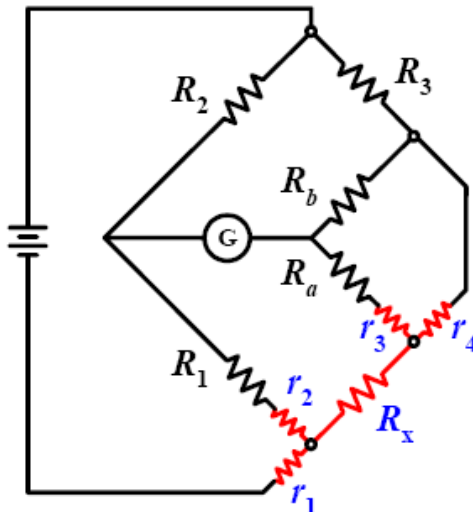
Four probe measurement in bridge configuration

Four-Terminal Resistor




Four-terminal resistors have current terminals and potential terminals. The resistance is defined as that between the potential terminals, so that contact voltage drops at the current terminals do not introduce errors.

Four-Terminal Resistor and Kelvin Double Bridge



- r_1 causes no effect on the balance condition.
- The effects of r_2 and r_3 could be minimized, if $R_1 \gg r_2$ and $R_a \gg r_3$.
- The main error comes from r_4 , even though this value is very small.



VOL. 13 No. 1

FEBRUARY 1958

Philips Research Reports

EDITED BY THE RESEARCH LABORATORY
OF N.V. PHILIPS' GLOEILAMPENFABRIEKEN, EINDHOVEN, NETHERLANDS

R 334

Philips Res. Repts 13, 1-9, 1958

A METHOD OF MEASURING SPECIFIC RESISTIVITY AND HALL EFFECT OF DISCS OF ARBITRARY SHAPE

by L. J. van der PAUW

537.723.1:53.081.7+538.632:083.9

Summary

A method of measuring specific resistivity and Hall effect of flat samples of arbitrary shape is presented. The method is based upon a theorem which holds for a flat sample of arbitrary shape if the contacts are sufficiently small and located at the circumference of the sample. Furthermore, the sample must be singly connected, i.e., it should not have isolated holes.



Resistivity measurements: van der Pauw method

Very popular in semiconductor industry
Does not require sample of regular shape

Assumptions

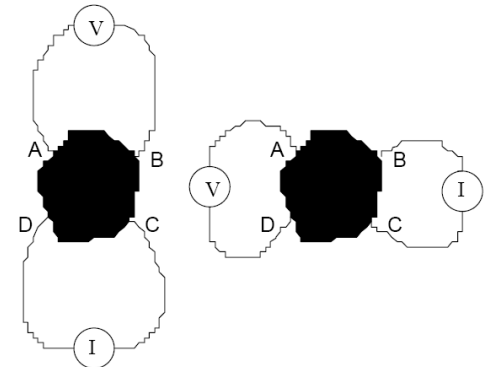
1. Homogeneous sample
2. Isotropic sample
3. Two-dimensional, thickness is unimportant
4. Sample boundary sharply defined

Surface resistance

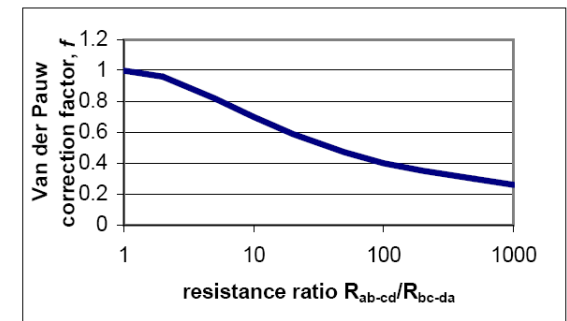
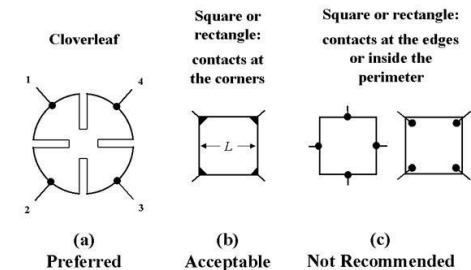
$$\rho_{\square} = \frac{\pi}{\ln 2} \frac{R_{ab-cd} + R_{bc-da}}{2} f$$

Resistivity

$$\rho = \frac{\pi}{\ln 2} W \frac{R_{ab-cd} + R_{bc-da}}{2} f$$



The contact arrangements for the two resistance measurements, R_{ab-cd} and R_{bc-da} used in the Van der Pauw resistivity measurement.



Correction factor based on the ratio of the two resistance measurements, R_{ab-cd} and R_{bc-da} used in the Van der Pauw resistivity measurement.



Method for Measuring Electrical Resistivity of Anisotropic Materials

H. C. MONTGOMERY

Bell Telephone Laboratories, Incorporated, Murray Hill, New Jersey 07974

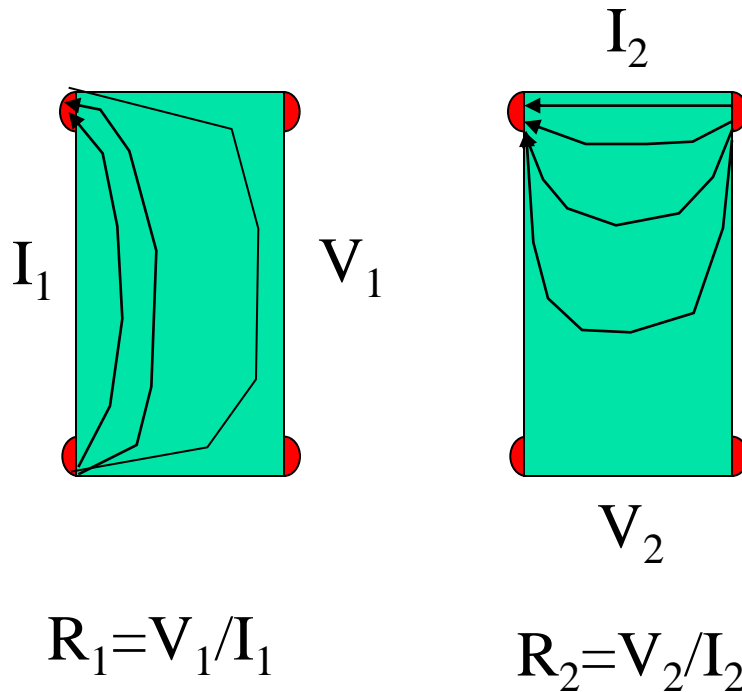
(Received 30 November 1970)

A rectangular prism with edges in principal crystal directions is prepared with electrodes on the corners of one face. Voltage-current ratios for opposite pairs of electrodes permit calculation of components of the resistivity tensor. The method can use small samples, and is best suited to materials describable by two or three tensor components. Examples are given of measurements of V_2O_5 -Cr and oriented amorphous graphite.

Montgomery technique

$$(\rho_2/\rho_1)^{1/2} = (l_2/l_1) \times (l_1'/l_2').$$

1. Van der Pauw resistivity measurements on samples of rectangular



2. Calculation of the anisotropy ratio for isotropic samples

3. Scaling anisotropic samples on isotropic by van der Pauw scaling transformation

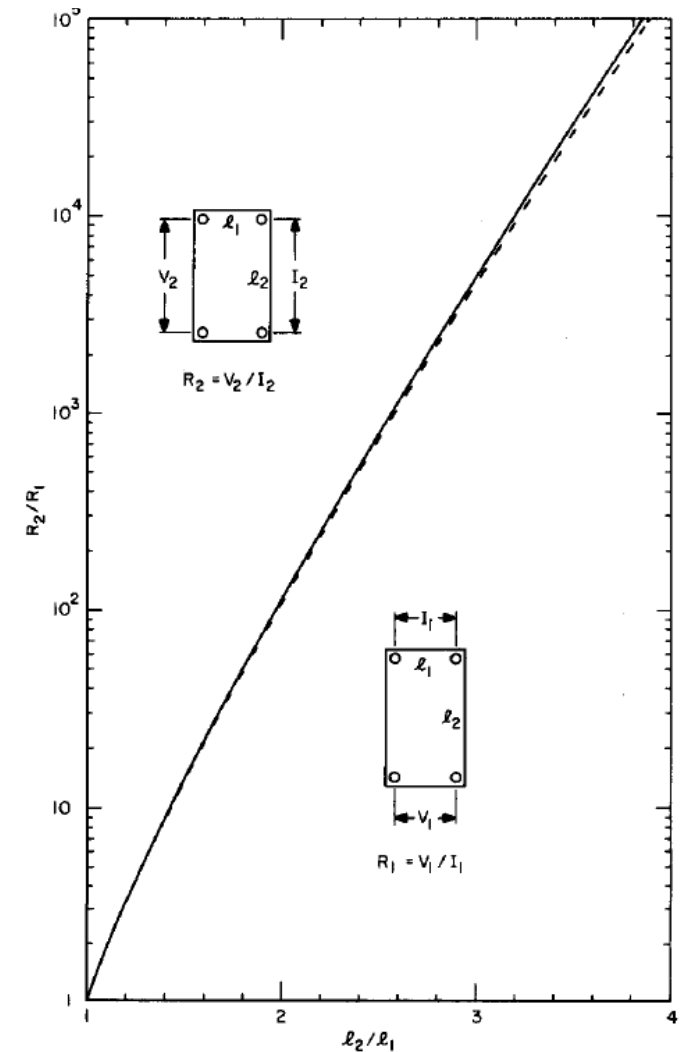


FIG. 3. Resistance ratio versus sample dimension ratio. Solid line is for a thin sample; dashed line for a thick sample. Details of thickness dependence given in Table II.



Interference Factor

- Ohmic contact quality and size
- Sample uniformity and accurate thickness determination
- Photoconductive and photovoltaic effects



Reading

1. Low Level Measurements Handbook, Keithley www.keithley.com
2. Lake Shore manual for LS370
3. J. M. Ziman, Principles of the Theory of Solids, 1964